

Docket No. 218282US6X

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Hiroyuki WADA, et al.

GAU:

2812

SERIAL NO: 10/050,542

EXAMINER:

FILED:

January 18, 2002

FOR:

APPARATUS FOR EVALUATING POLYSILICON FILM

REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

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It is hereby requested that a two month extension of time be granted to June	e 15, 2002 for
filing a response to the Official Action dated:	
responding to the requirements in the Notice of Allowability dated:	
☐ filing the Formal Drawings. The Issue Fee due	has been timely filed.
responding to the Notice to File Missing Parts of Application dated:	February 15, 2002
filing a Notice of Appeal. A timely response to the final rejection, due	has been filed.
☐ filing an Appeal Brief. A Notice of Appeal was filed on:	
☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the f	ee amount shown below is reduced by one-half
The required fee of \$400.00 is enclosed herewith by check and any further of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is en	

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Gregory J. Maier

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